

Attorney Docket: 021906-0307405
Client Reference: PIA31178/DBE/US-HO

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
LEE

Confirmation Number: 9617

Application No.: 10/743,454

Group Art Unit: 2823

Filed: December 23, 2003

Examiner: Estrada, Michelle

Title: METHOD FOR PLANARIZING A SURFACE OF A SEMICONDUCTOR WAFER

AMENDMENT

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401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Office Action dated March 23, 2005, please amend the above-identified application as follows: